

Search Notes



Application/Control No.

09/829,793

Applicant(s)/Patent under
Reexamination

EMONS, MARTIJN
JOHANNES LAMBERTUS

Examiner

Hong C. Kim

Art Unit

2186

SEARCHED

| Class | Subclass | Date | Examiner |
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| 711 | 137 139 | 6/6/05 | rdh |
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INTERFERENCE SEARCHED

| Class | Subclass | Date | Examiner |
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)

| | DATE | EXMR |
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